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**INFORMATION DISCLOSURE
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517657

Sheet	1	of	1	Application Number	Not yet assigned
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				Filing Date	December 13, 2004
				First Named Inventor	Enzo DI FABRIZIO
				Art Unit	Not yet assigned
				Examiner Name	Not yet assigned
				Attorney Docket Number	Q85169

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code ² (if known)		
		US 2002/050711	A1	05/2/2002	Waiti, et al.
		US 2002/022682	A1	09/20/2001	McClelland
		US 5,487,012		01/23/1996	Tophelm et al.

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation ⁶
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)			
		BE	1 010 200	A	03/03/1998	Variphone Benelux Naamloze Ven	
		WO	02/091920		11/21/2002	OTICON AS	

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation ⁶
		Xie Huikai et al.: "A SCS SMOS Micromirror for Optical Coherence Tomographic Imaging" Technical Digest., MEMS 2002 IEEE International Conference on Micro Electro Mechanical Systems, Las Vegas. NV, USA, January 20, 2002-January 24, 2002, pages 495-498, XP010577701, Piscataway, NJ, USA, ISBN: 0-7803-7185-2, pages 497-487, section "OCT application" abstract	
		J. Micromech. Microeng. 13, 2003, pages 383-389	

Examiner Signature	Date Considered
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